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P/4303-34

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Valentin Chitic, et al.

Date: February 8, 2005

Serial No.: 10/780,334

Group Art Unit: 3635

Filed: February 17, 2004

Examiner: Christie Marie Green

For: HOLLOW SECTION AND PROCESS FOR ITS
MANUFACTURE

Confirmation No.: 1098

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO 1449.

The present Information Disclosure Statement is being submitted prior to issuance of a first Office Action on the merits.

The references were cited in a European application corresponding to the present application. A copy of the European Search Report is enclosed.

Swiss Patent No. CH 691 731 A and German Patent Nos. DE 198 51 326 C1 and DE 35 32 499 C1 are not enclosed because they were previously cited in an Information Disclosure Statement filed on July 12, 2004. U.S. Patent No. 5,404,974 is also not enclosed. Copies of the remaining references cited in the European Search Report are enclosed.

I certify that each item of information contained in this Submission was first cited in a communication from a foreign patent office in a counterpart foreign application not more than 3 months prior to the filing of this Submission.

The present invention defines a hollow section and process for its manufacture which is not believed to be disclosed by the enclosed references.

In accordance with 37 C.F.R §§1.97(g) and (h), the filing of this Information Disclosure Statement should not be construed as a representation that a search has been made or that information cited is, or is considered to be, material to patentability as defined in §1.56(b), or that any cited document listed or attached is (or constitutes) prior art. Unless otherwise indicated, the date of publication indicated for an item is taken from the face of the item and applicants reserve the right to prove that the date of publication is in fact different.

It is respectfully requested that the above information be considered by the Examiner and that the copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

In the event the fee is inadvertently not enclosed or if any additional fee during the prosecution of this application is not paid, the Patent Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on February 8, 2005:

Klaus P. Stoffel

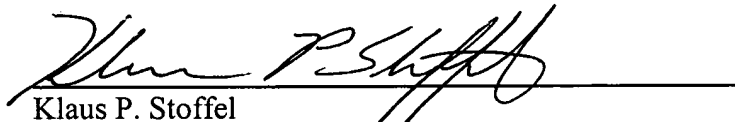
Name of applicant, assignee or
Registered Representative


Signature

February 8, 2005

Date of Signature

Respectfully submitted,


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APPLICANT'S ART CITATION (Use several sheets if necessary)		Application 10/780,334		OFGS File No. P/4303-34	
		Applicant Valentin Chitic, et al.			
		Filing Date February 17, 2004		Group Art Unit 3635	

OFFICE OF
 PATENT & TRADEMARKS
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U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-5,404,974	04-1995	Thum et al.			
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					

FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
	EP 0 601 394 A2	06-1994	EPO			X (Abstract)	
	EP 1 329 363 A1	07-2003	EPO			X (Abstract)	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		

Examiner	Date Considered
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.